



PATENT
3430-0149P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Jeong-Jin KIM et al. Conf. No.: 5548
Appl. No.: 09/727,516 Group: 1765
Filed: December 4, 2000 Examiner: A. K. ALANKO
For: METHOD OF ETCHING AND CLEANING OBJECTS

REQUEST FOR RECONSIDERATION AFTER FINAL

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*Entered per
RCE filed
2/6/06
[signature]*

Sir:

In response to the Examiner's Office Action dated October 5, 2005, Applicants respectfully submit the following Remarks in connection with the above-identified application.

This reply includes

Remarks.